

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1722**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITSU et al.

Group Art Unit: 1722

Application No.: 10/509,177

Examiner: M. SONG

Filed: September 27, 2004

Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR A1-CONTAINING III-V GROUP  
COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR  
PRODUCING A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 18, 2007 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**